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APPLICATION NO.	FILING DA	TE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/781,706	02/20/20	04	Chandra Mouli	M4065.0986/P986	4202	
24998	7590 03	3/24/2006		EXAMINER		
	N SHAPIRO M	VU, HUNG K				
2101 L Stree Washington	et, NW , DC 20037			ART UNIT	ART UNIT PAPER NUMBER	
g	,			2811		
				DATE MAILED: 03/24/200	6	

Please find below and/or attached an Office communication concerning this application or proceeding.

			hi.					
1	Application No.	Applicant(s)						
	10/781,706	MOULI, CHANDRA						
Office Action Summary	Examiner	Art Unit						
	Hung Vu	2811						
The MAILING DATE of this communication appeared for Reply	pears on the cover sheet with	the correspondence address						
A SHORTENED STATUTORY PERIOD FOR REPI WHICHEVER IS LONGER, FROM THE MAILING [- Extensions of time may be available under the provisions of 37 CFR 1 after SIX (6) MONTHS from the mailing date of this communication If NO period for reply is specified above, the maximum statutory period Failure to reply within the set or extended period for reply will, by statu Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	DATE OF THIS COMMUNICA: .136(a). In no event, however, may a reply d will apply and will expire SIX (6) MONTHS te, cause the application to become ABANI	TION. be timely filed from the mailing date of this communication DONED (35 U.S.C. § 133).						
Status								
1)⊠ Responsive to communication(s) filed on 29 l	December 2005.							
3) Since this application is in condition for allows								
closed in accordance with the practice under	Ex parte Quayle, 1935 C.D. 1	1, 453 O.G. 213.						
Disposition of Claims								
4) Claim(s) <u>1-48</u> is/are pending in the application	n							
•	4a) Of the above claim(s) <u>4,5,12,13,17-19,21,25 and 35-48</u> is/are withdrawn from consideration.							
5) Claim(s) is/are allowed.								
. —	⊠ Claim(s) <u>1-3,6-11,14-16,20,22-24 and 26-34</u> is/are rejected.							
7) Claim(s) is/are objected to.	•							
8) Claim(s) are subject to restriction and/	or election requirement.							
Application Papers								
9) The specification is objected to by the Examir10) The drawing(s) filed on is/are: a) ac		the Evaminer						
•								
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a). Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).								
11) The oath or declaration is objected to by the E			. ,					
Priority under 35 U.S.C. § 119								
	un priority under 35 H.S.C. & 1:	19(a)-(d) or (f)						
12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) All b) Some * c) None of:								
a) ☐ All b) ☐ Some c) ☐ None of. 1. ☐ Certified copies of the priority documents have been received.								
2. Certified copies of the priority documents have been received in Application No								
3. Copies of the certified copies of the priority documents have been received in this National Stage								
application from the International Bureau (PCT Rule 17.2(a)).								
* See the attached detailed Office action for a list of the certified copies not received.								
Attachment(s)								
1) Notice of References Cited (PTO-892)	4) Interview Sum							
 2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/03) 	C	Mail Date mal Patent Application (PTO-152)						
Paper No(s)/Mail Date	6) Other:							

DETAILED ACTION

Election/Restrictions

1. Applicant's election with traverse of Embodiment 1, claims 1-3, 6-11, 14-16, 20, 22-24 and 26-34, in the reply filed on 12/29/05 is acknowledged. The traversal is on the ground(s) that examination of the claims of Embodiment 1 will necessarily include a search and examination of subject matter included in the Embodiment 1-4, therefore, no undue burden would be involved in examining the claims of Embodiment 1-4 together. This is not found persuasive because it is well settled that species are required to be restricted if it is shown that these species are distinct. It is clearly established that species are in fact distinct in the Restriction requirement.

The requirement is still deemed proper and is therefore made FINAL.

2. Claim 34 is not belong to the elected embodiment and claims 4, 5, 12, 13, 17-19, 21, 25 and 35-48 are withdrawn from further consideration pursuant to 37 CFR 1.142(b), as being drawn to a nonelected Embodiment, there being no allowable generic or linking claim. Applicant timely traversed the restriction (election) requirement in the reply filed on 12/29/05.

Claim Rejections - 35 USC § 102

3. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(e) the invention was described in (1) an application for patent, published under section 122(b), by another filed in the United States before the invention by the applicant for patent or (2) a patent granted on an application for patent by another filed in the United States before the invention by the applicant for patent, except that an international application filed under the treaty defined in section 351(a) shall have the effects for purposes of this subsection of an application filed in the United States only if the international application designated the United States and was published under Article 21(2) of such treaty in the English language.

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Claims 1 and 10 are rejected under 35 U.S.C. 102(e) as being anticipated by Clevenger et al. (US 2004/0227061).

Clevenger et al. discloses, as shown in Figures 1-13, an image sensor comprising:

a substrate (100B) formed over a base layer (100A);

a plurality of pixel cells (104A,104B) formed within the substrate, each pixel cell comprising a photo-conversion device;

a plurality of trenches (116A,116B), each trench being provided along a perimeter of a respective pixel cell, each trench extending to a surface of the base layer, each trench having sidewalls, and being at least partially filled with a material that prevents at least a portion of electrons from passing through the trench.

Regarding claim 10. Clevenger et al. discloses the sensor comprises a CMOS image sensor.

Claim Rejections - 35 USC § 103

- 4. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claims 8 and 9 are rejected under 35 U.S.C. 103(a) as being unpatentable over Clevenger et al. (US 2004/0227061) in view of Rhodes (US 2003/0089929).

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Clevenger et al. discloses the claimed invention including the sensor as explained in the rejection above. Clevenger et al. does not disclose the depth of the trench being greater than about 200 Angstroms. However, Rhodes discloses disclose a trench having the depth of at least about 500 angstroms to 10 um. Note Figure and section [0056] of Rhodes. Therefore, it would have been obvious to one of ordinary skill in the art at the time the invention was made to form the trench of Clevenger et al. having the depth of as claimed, such as taught by Rhodes in order to further prevent the electrons from passing to the adjacent devices.

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5. Claims 2, 3, 6, 7, 14-16, 20, 22-24 and 26-34 are rejected under 35 U.S.C. 103(a) as being unpatentable over Clevenger et al. (US 2004/0227061) in view of Rhodes (US 2003/0089929) and further in view of Yoshinori (JP 363009968).

Clevenger et al. and Rhodes disclose the claimed invention including the sensor as explained in the rejection above. Clevenger et al. and Rhodes do not disclose a thermal oxide on the sidewalls of the trench structure, and the first material selected from the group consisting of undoped polysilicon. However, Yoshinori discloses a thermal oxide (26) on the sidewalls of the trench, and the filled material (27) comprising an undoped polysilicon. Therefore, it would have been obvious to one of ordinary skill in the art at the time the invention was made to form the trench of Clevenger et al. and Rhodes having the thermal oxide on the sidewall of the trench and the filled material of undoped polysilicon, such as taught by Yoshinori in order to further prevent the electrons from passing through the isolation structure.

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Regarding claims 16 and 28, the term "high-density plasma oxide and spin on dielectric oxide" is method recitation in a device claimed. "[E]ven though product-by-process claims are limited by and defined by the process, determination of patentability is based on the product itself. The patentability of a product does not depend on its method of production. If the product in the product-by-process claim is the same as or obvious from a product of the prior art, the claim is unpatentable even though the prior product was made by a different process." *In re Thorpe*, 777 F.2d 695, 698, 227 USPQ 964, 966 (Fed. Cir. 1985).

Regarding claims 22-23 and 30-32, Clevenger et al., Rhodes and Yoshinori disclose the trench has a depth greater than 2000 Angstroms.

Regarding claims 24 and 32, Clevenger et al., Rhodes and Yoshinori disclose the semiconductor device comprises a CMOS image sensor.

Regarding claim 26, Clevenger et al., Rhodes and Yoshinori disclose a processor.

Regarding claims 11 and 33, Clevenger et al., Rhodes and Yoshinori do not disclose the semiconductor device comprises a CCD image sensor. However, Clevenger et al., Rhodes and Yoshinori disclose a CCD image sensor has some advantages such as smaller size than the CMOS image sensor. Therefore, it would have been obvious to one of ordinary skill in the art at the time the invention was made to form the device of Clevenger et al., Rhodes and Yoshinori comprising CCD image sensor in order to reduce the size and to improve the circuit density.

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Conclusion

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6. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Hung Vu whose telephone number is (571) 272-1666. The

examiner can normally be reached on Tuesday to Friday 6:00-4:30.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's

supervisor, Eddie C. Lee can be reached on (571) 272 - 1732. The fax phone number for the

organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent

Application Information Retrieval (PAIR) system. Status information for published applications

may be obtained from either Private PAIR or Public PAIR. Status information for unpublished

applications is available through Private PAIR only. For more information about the PAIR

system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR

system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Vu

March 16, 2005

Hung Vu

Primary Examiner